

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 10/082,599  
Priority Filing Date ..... February 22, 2002  
 Inventor ..... Craig M. Carpenter et al.  
 Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 1763  
Priority Examiner ..... Karla A. Moore  
 Attorney's Docket No. .... MI22-2433  
 Customer No. .... 021567  
 Title: Semiconductor Substrate Processing Chamber and Accessory  
 Attachment Interfacial Structure (as Amended)

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
 Commissioner for Patents  
 P. O. Box 1450  
 Alexandria, VA 22313-1450

**VIA EXPRESS MAIL**

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Please enter the following amendments prior to examining the above-identified application.

**AMENDMENTS**

**Amendments to the Title**

Please change the title to the following: --SEMICONDUCTOR  
SUBSTRATE PROCESSING CHAMBER AND ACCESSORY ATTACHMENT  
INTERFACIAL STRUCTURE--.